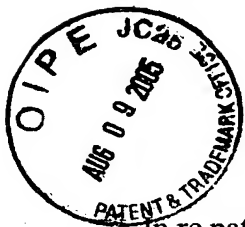


IPW

Docket No. GNE518 US ARI.027



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Noboru MORITA, et al.

Serial No.: 10/766,921

Group Art Unit: 2818

Filing Date: January 30, 2004

Examiner: Berry, Renee R.

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING
PLASMA-ENHANCED CVD

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

STATUS INQUIRY

Sir:

Please indicate the status of the above-identified application, including an indication as to when the first Office Action on the merits may be expected.

Respectfully submitted,

Sean M. McGinn, Esq.
Registration No. 34,386

Date:

8/9/05

McGinn & Gibb, PLLC
Intellectual Property Law
8321 Old Courthouse Road, Suite 200
Vienna, Virginia 22182-3817
(703) 761-4100
Customer No. 21254